



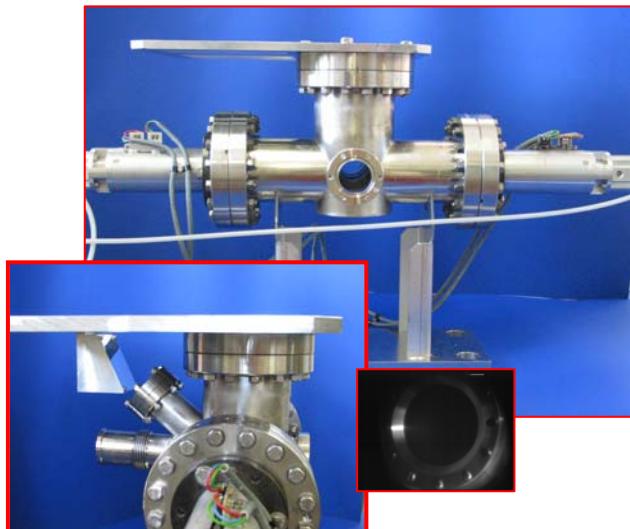
Beam Instrumentation



- Performances of Emittance Measurements
- Profile measurements in Spectrometer Line
- Time resolved energy measurements
- Delay loop Monitors
- Beam Halo Monitoring

For the CERN and INFN Beam diagnostic group

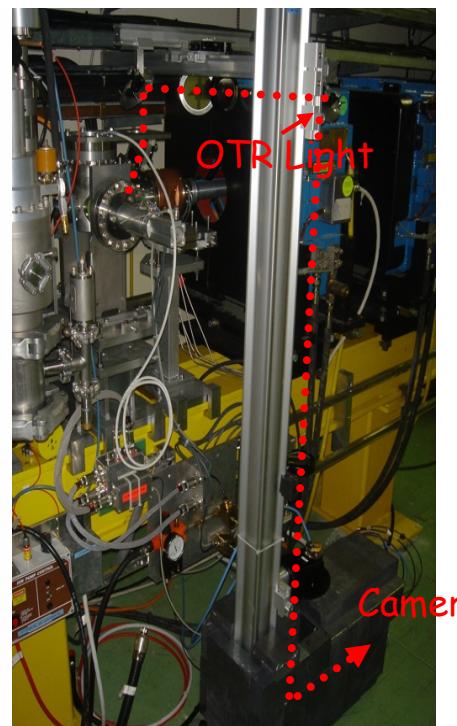
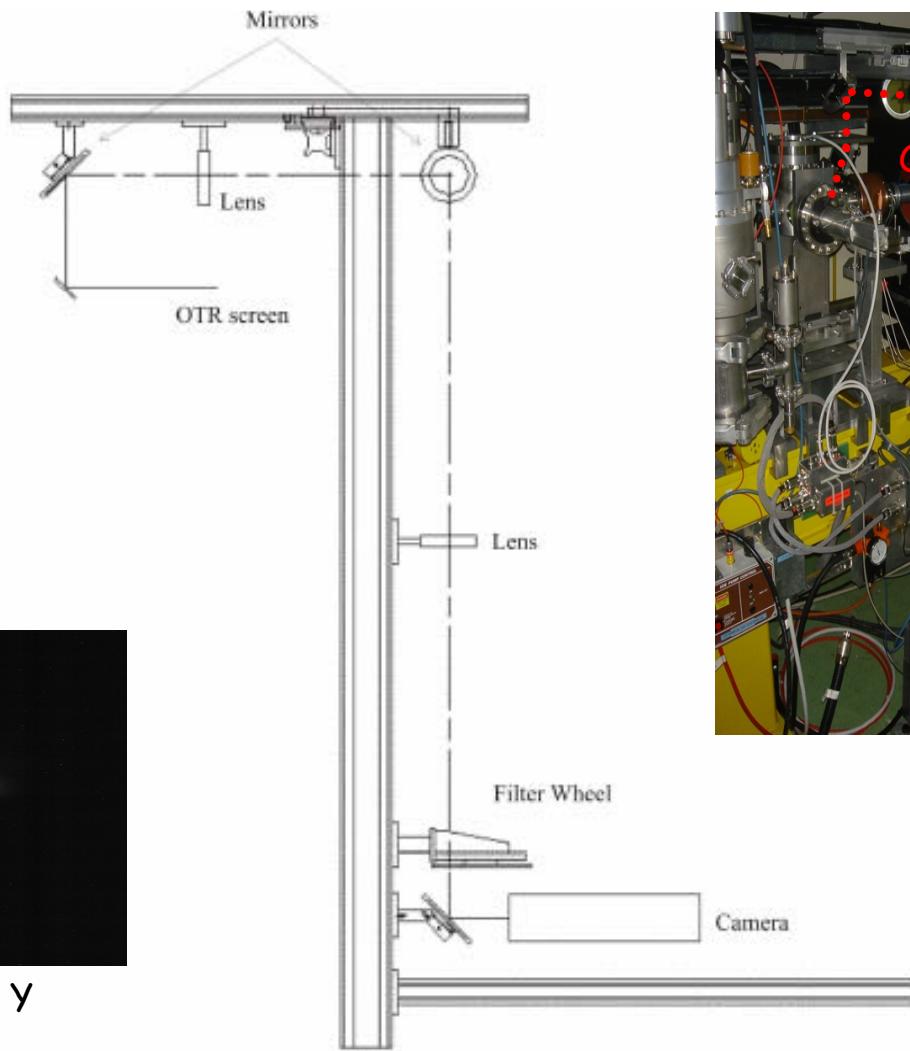
Emittance Measurements



Scan in X

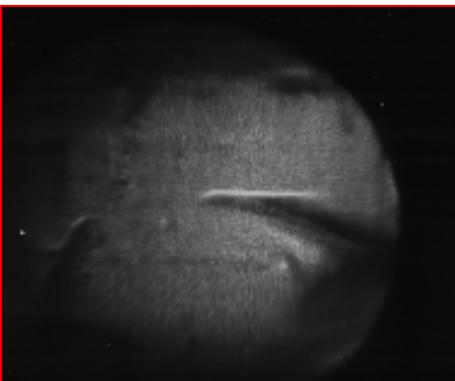


Scan in Y

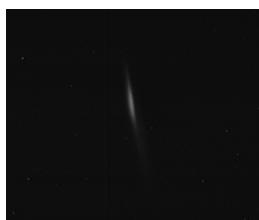


High reflectivity screens for low charge beam

- Thin Al foil is fragile

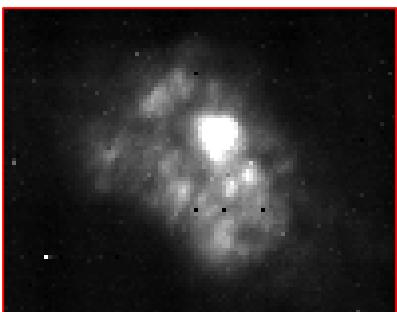


- Using 200 μm Si wafer with a very good surface quality
- Adding an Aluminum coating to provide an excellent reflectivity coefficient (90%)



Thermal resistant material for high charge beam

- Non homogeneous surface of C



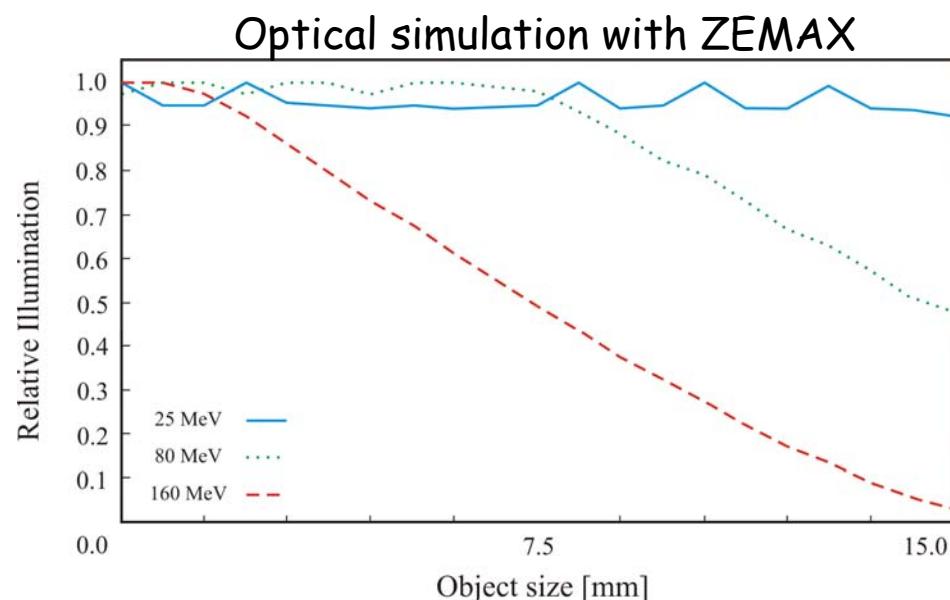
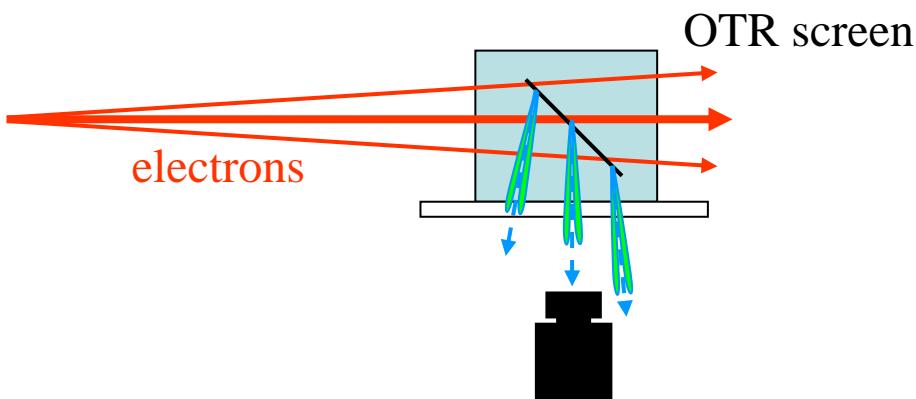
- 200 μm thick Polished CVD SiC



30% Reflectivity coefficient

OTR light intensity vs position

- The Light intensity changes as a function of the beam position. Maximum in the center of the screen, it then decreases rapidly for an off centered beam position
- This is due to the acceptance of the optical system, the small angular aperture ($\sim 1/\gamma$) of the OTR light and the size of the screen
- Effect stronger considering any beam angle

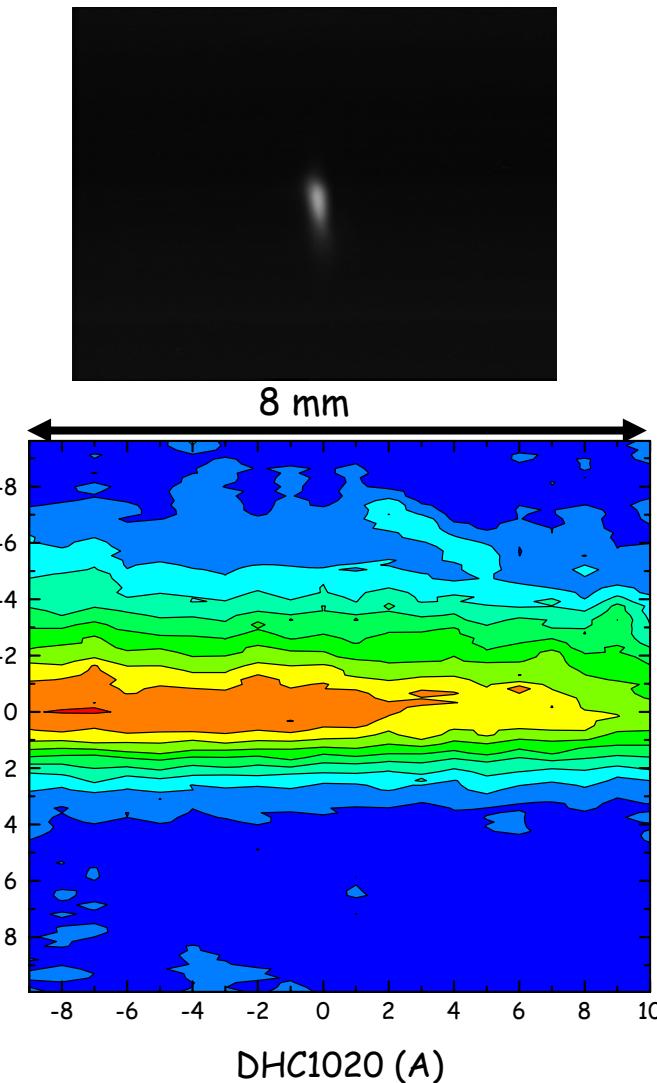




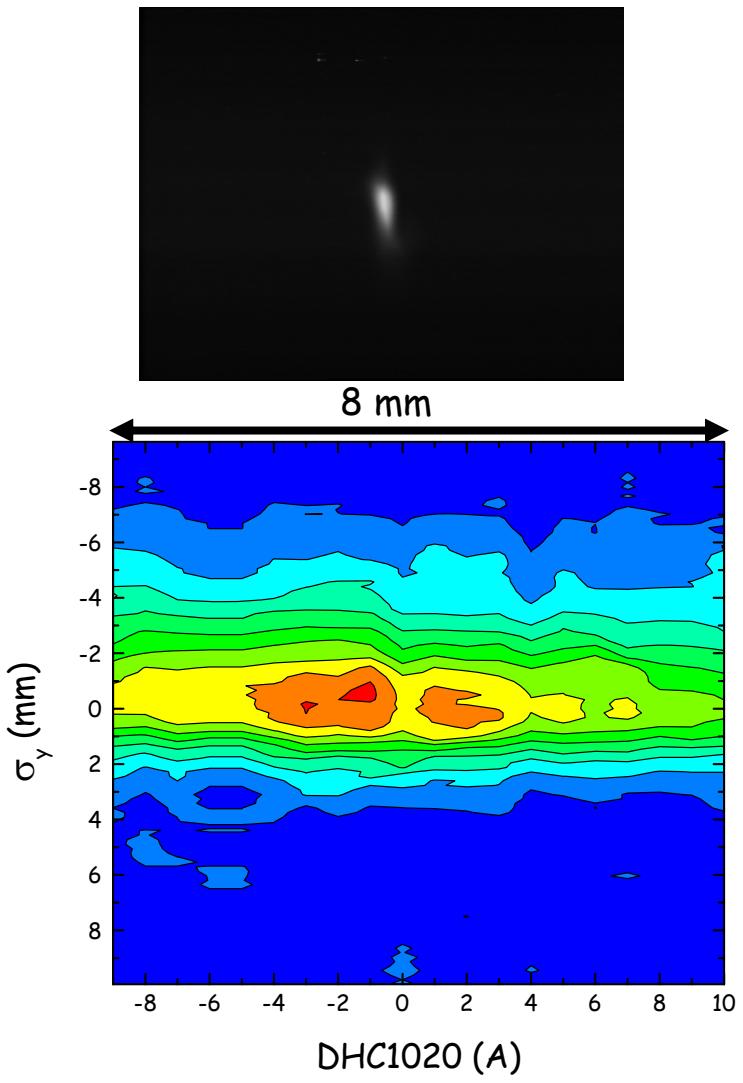
OTR light intensity vs position

@CL.MTV1030 - 93.5MeV

Carbon screen

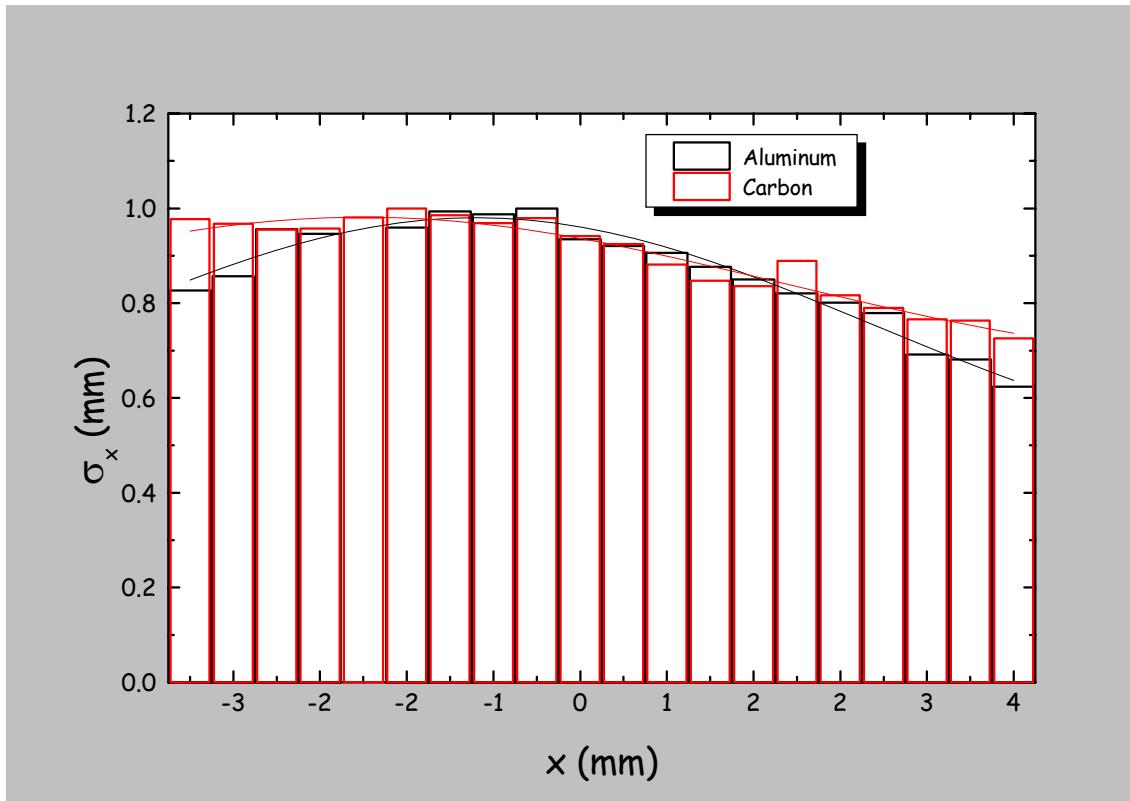


Aluminum screen



OTR light intensity vs position

@CL.MTV1030 - 93.5MeV

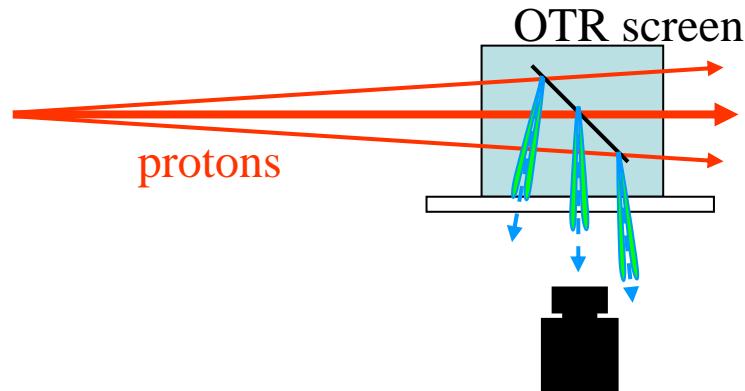


$$\begin{aligned}\sigma_{Al} &= 7.7\text{mm} \\ \Delta I_{Al} &= 37\% \text{ over } 8\text{mm} \\ \\ \sigma_C &= 8.6\text{mm} \\ \Delta I_C &= 28\% \text{ over } 8\text{mm}\end{aligned}$$



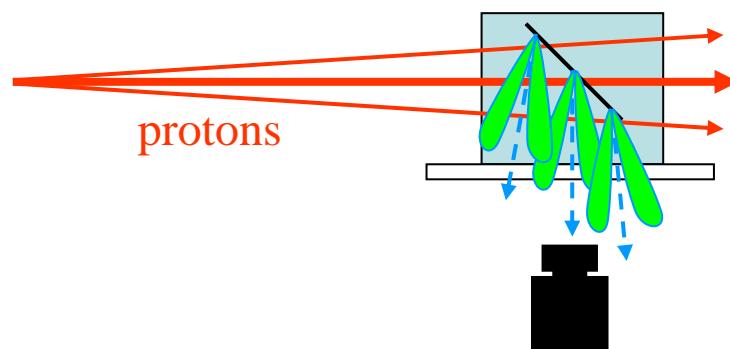
- Effect negligible for small beam size
- Smaller for diffusive screen surface (like carbon)

- Normal screen



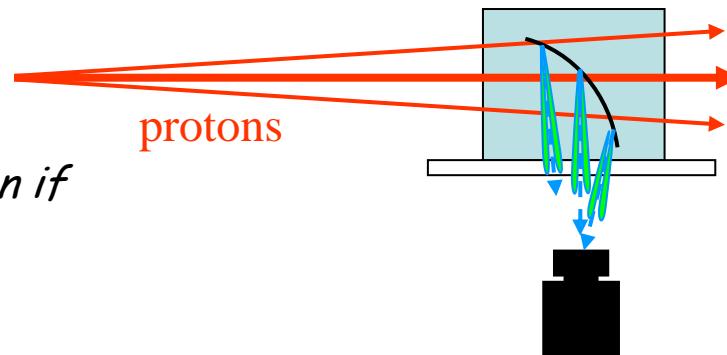
- Diffusive screen

- better homogeneity
- Less photons



- Parabolic screen

- Very good homogeneity
- No intensity diminution
- Very small image distortion if using large parabola ($\sim 1m$)

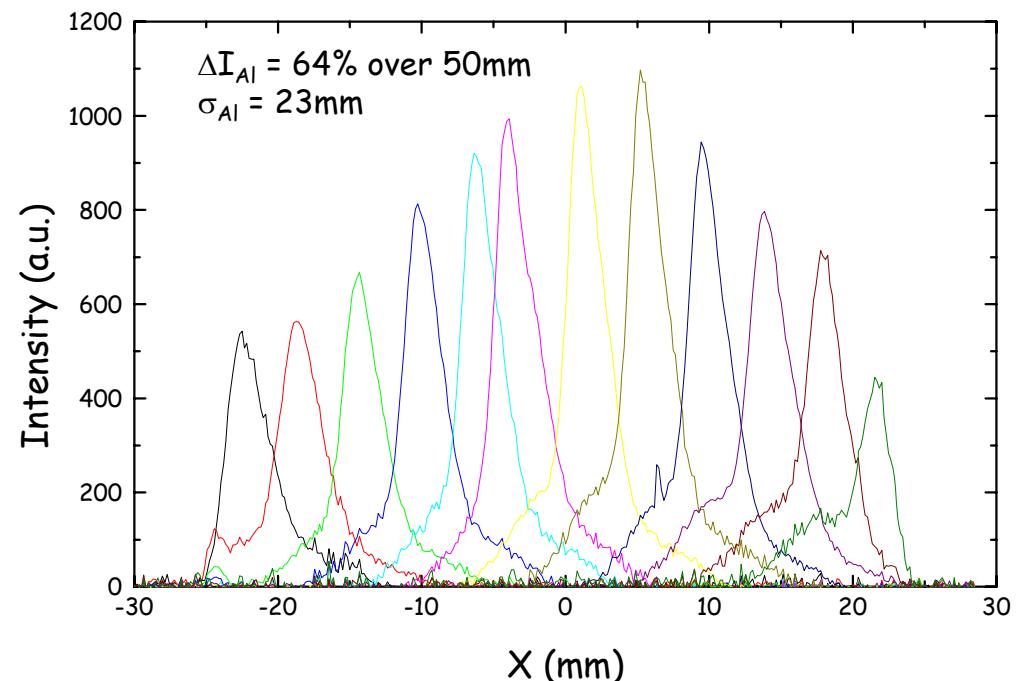
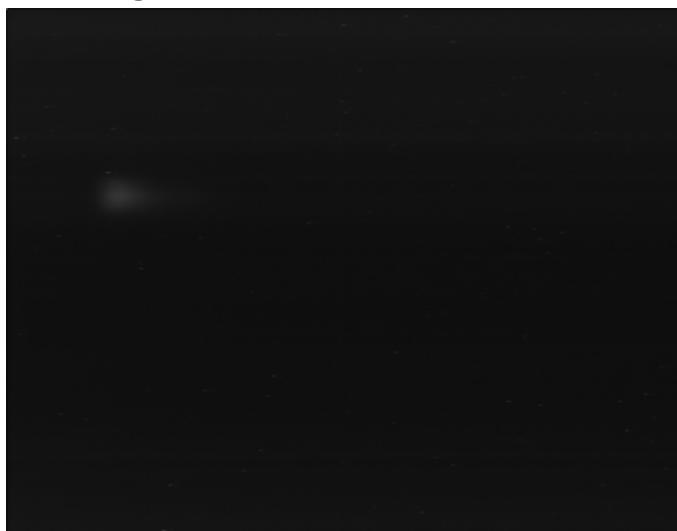


Screens in the spectrometer lines

Beam size is bigger in the dispersive region

@CTS.MTV0455 - delay loop beam - 1A

Using diffusive Aluminum foil

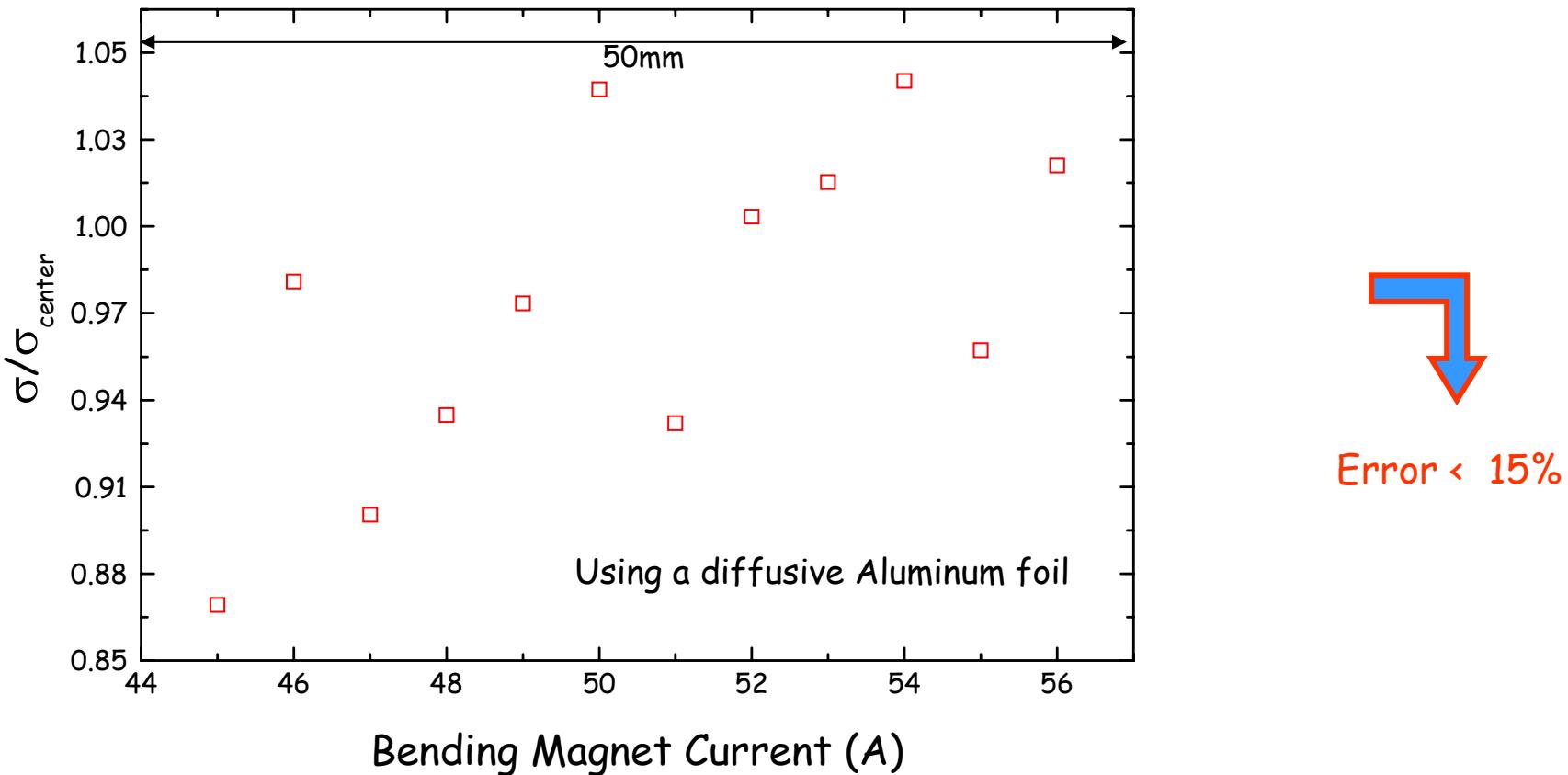


Deformation of the beam profile

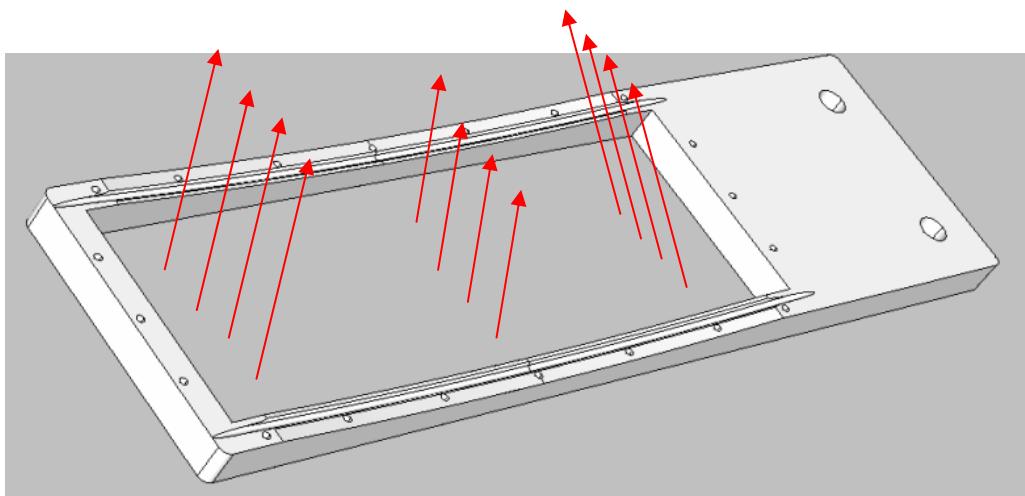
Screens in the spectrometer lines

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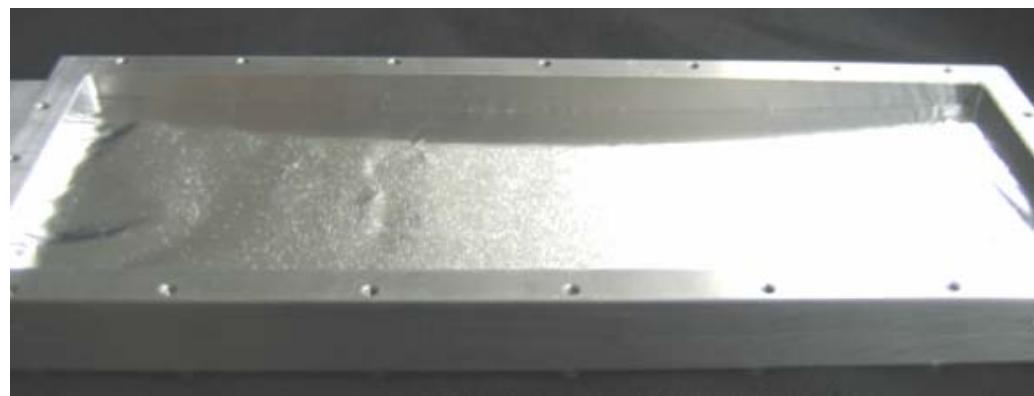


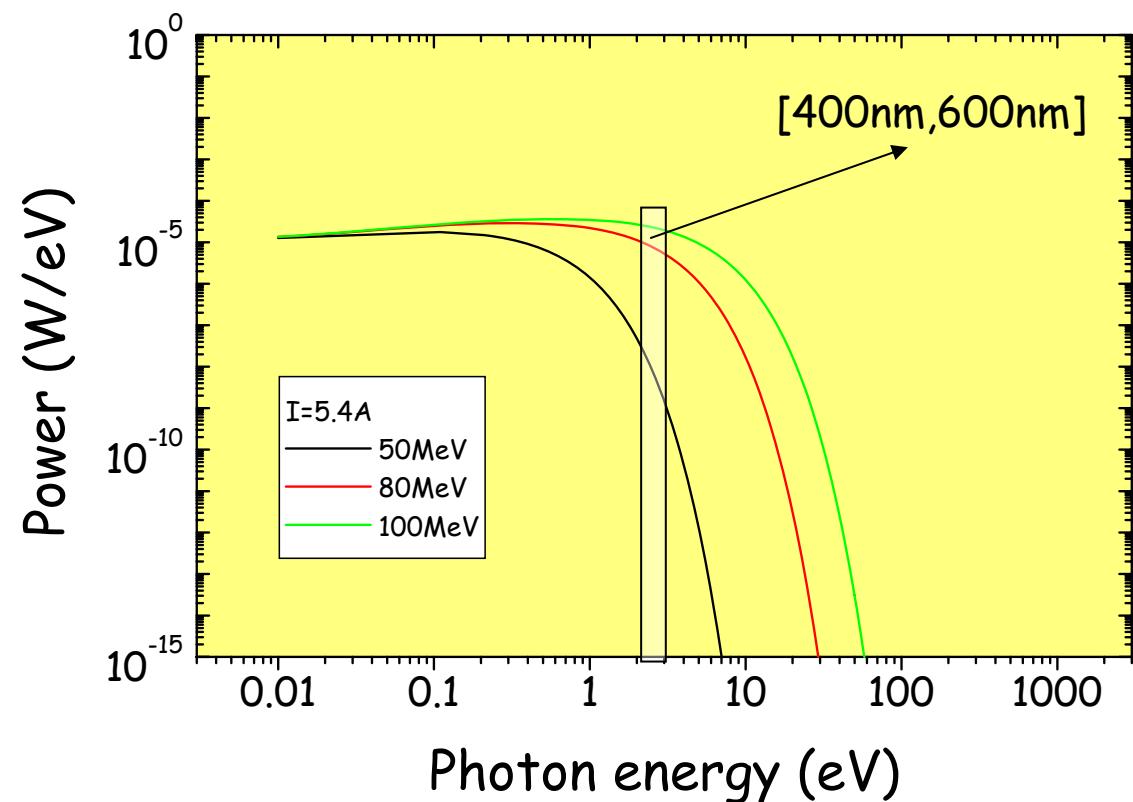
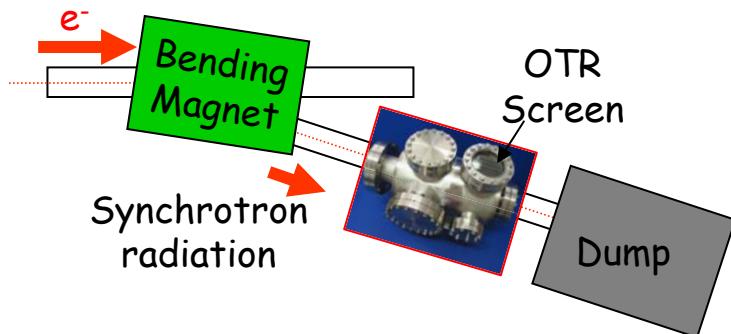
Parabolic Support



$$z = \frac{1}{4 \cdot f} \cdot x^2$$

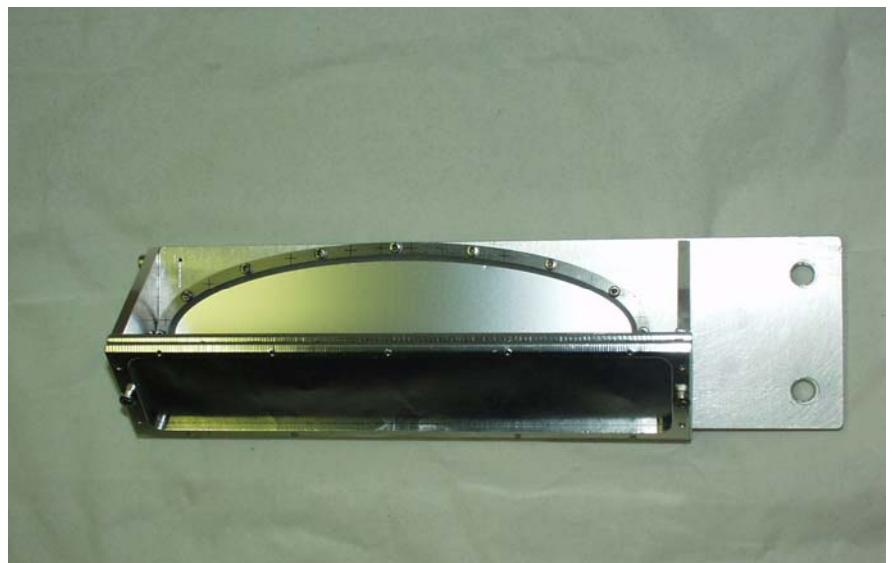
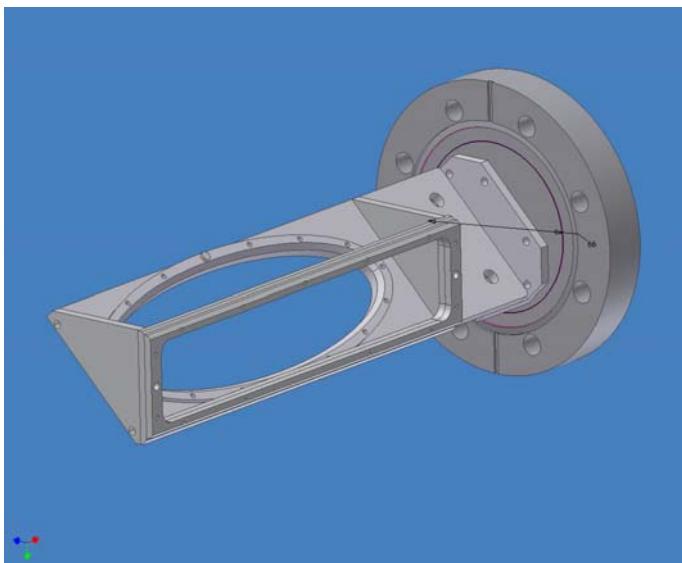
- Mechanic under development
- Ready for 2006



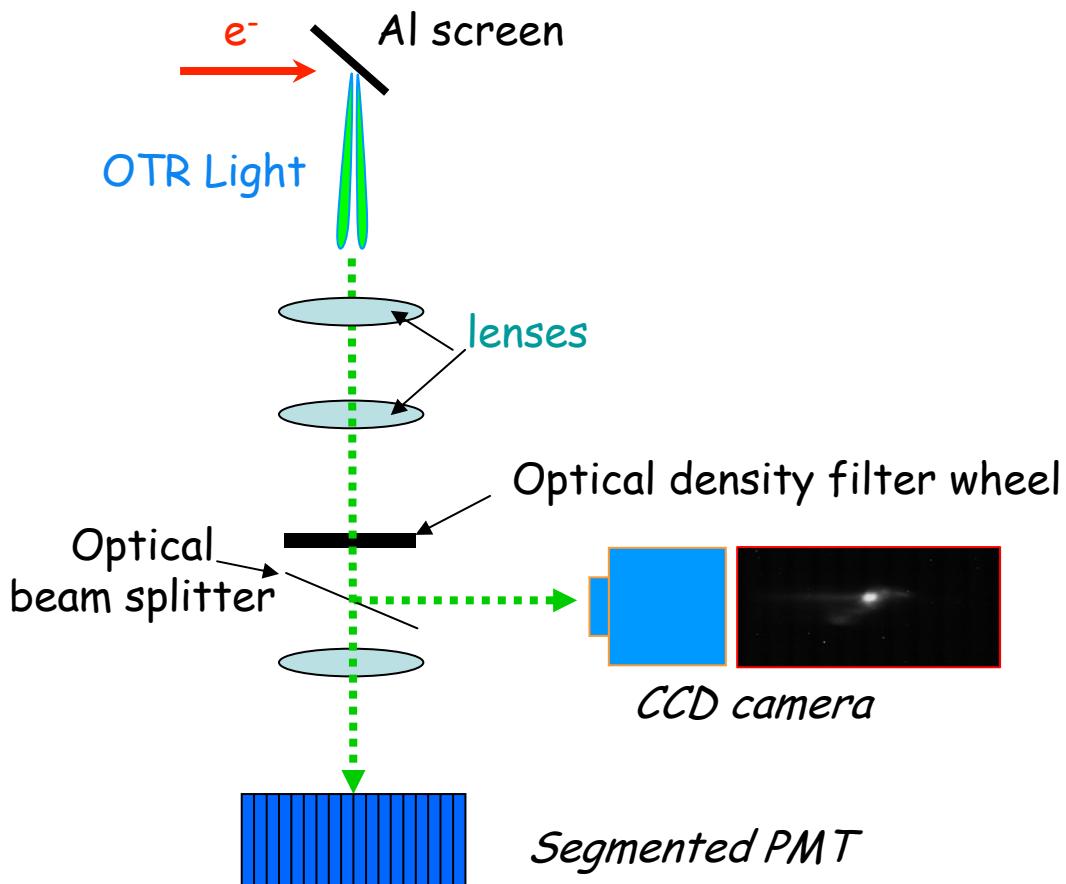


- At 50 MeV:
1.5 10^{-9} (SR) 7.7 10^{-3} (OTR)
- At 80 MeV :
5 10^{-4} (SR) 8.6 10^{-3} (OTR)
- At 100 MeV :
4 10^{-3} (SR) 9 10^{-3} (OTR)

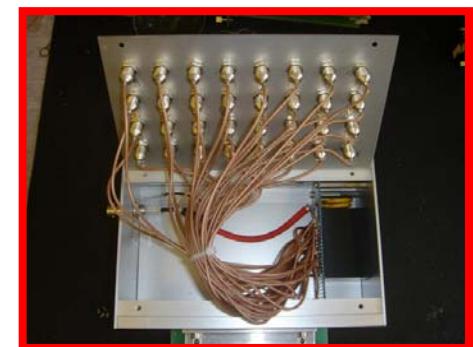
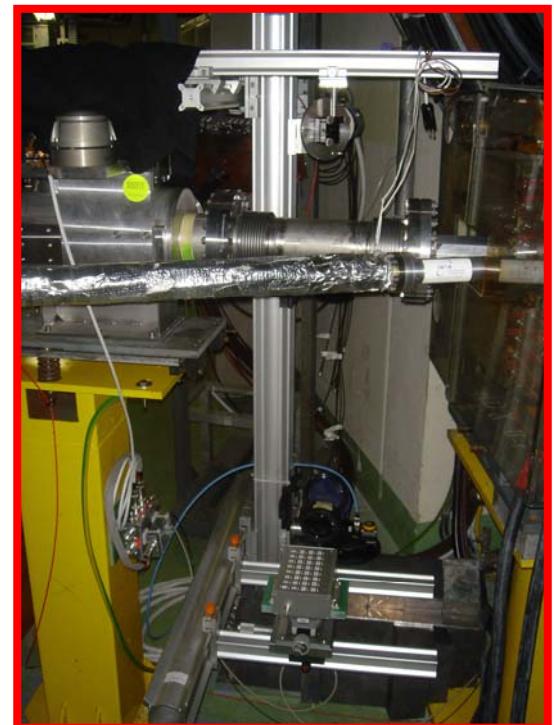
Carbon foil as a synchrotron light shielding



Already implemented in the last two spectrometer lines in the CTF line

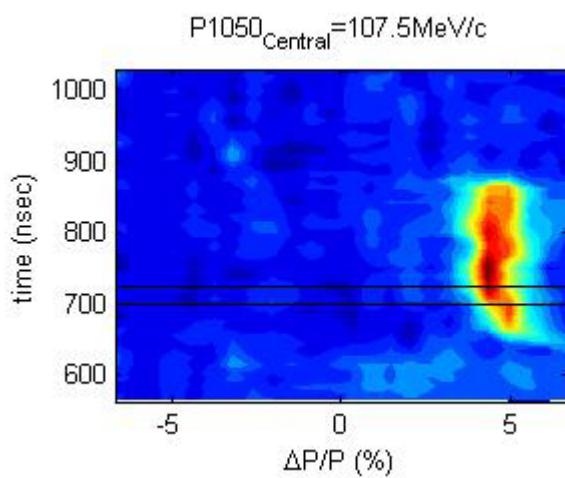
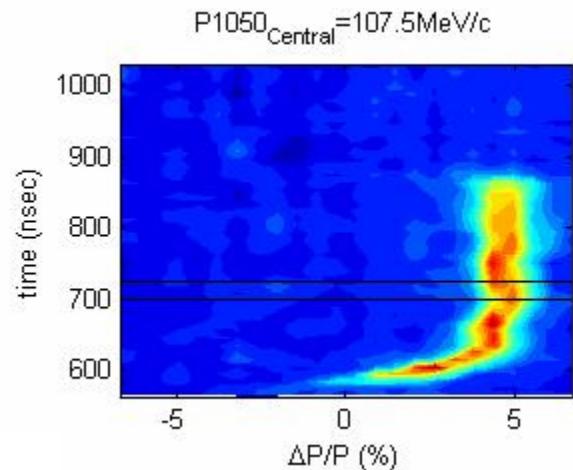
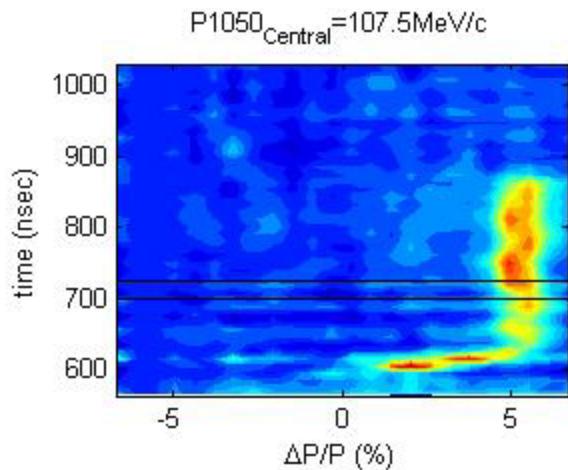


- Optical line magnification: 0.36
- Resolution of the PMT segments is 2.8mm
- Fast Amplifier sit in the klystron gallery close to the ADC

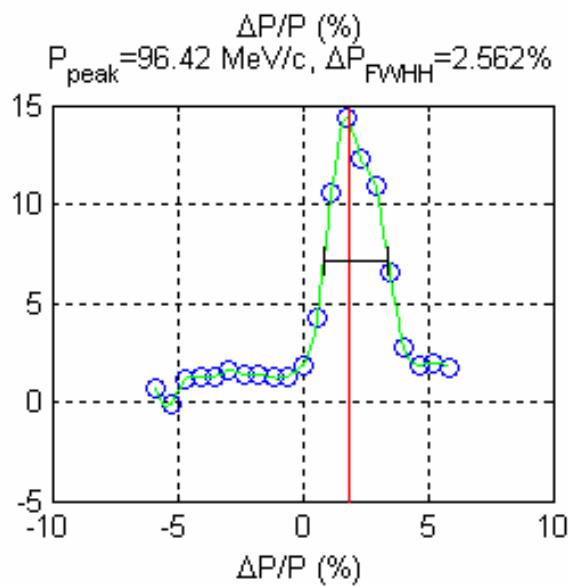
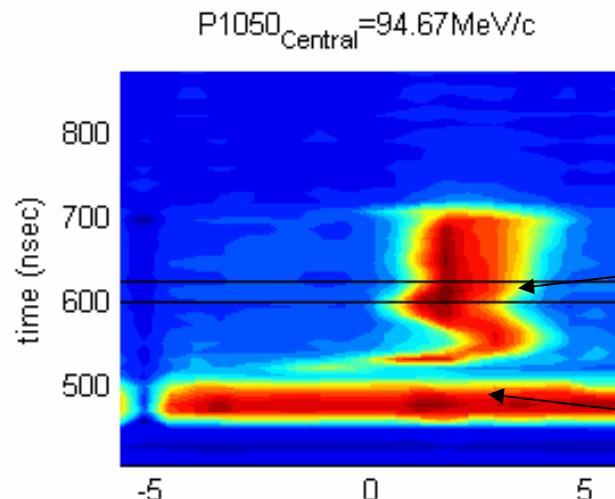


@CLS.SegPMT1050 - PETS Beam 3.5 A

Displacing klystron 5&6 for transient compensation

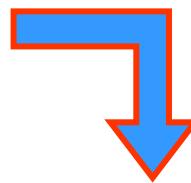


@CLS.SegPMT1050 - PETs Beam 5 A



Beam energy spectrum

Noise

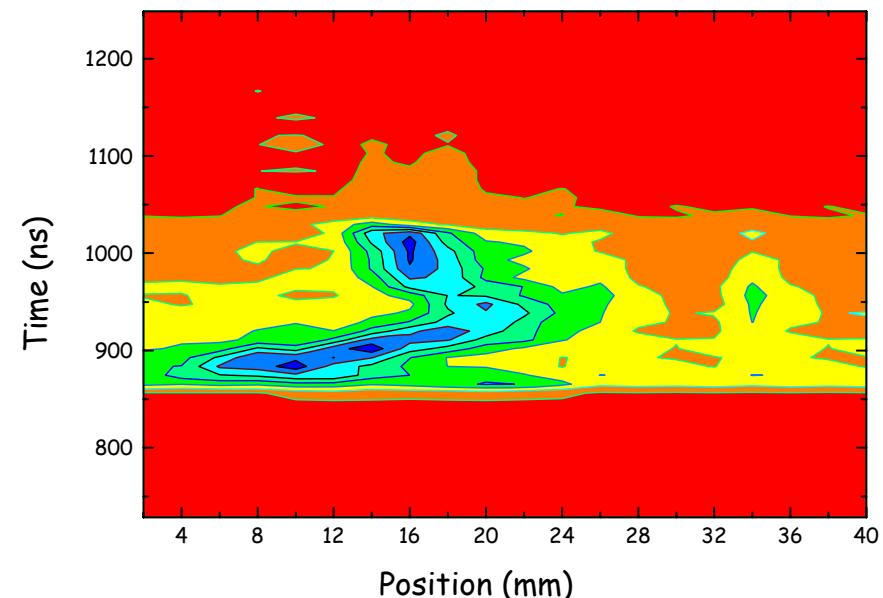


- Sources not identified clearly
- Sensitive to beam losses conditions

@CTS.SegPMT 0455 - Delay loop operation

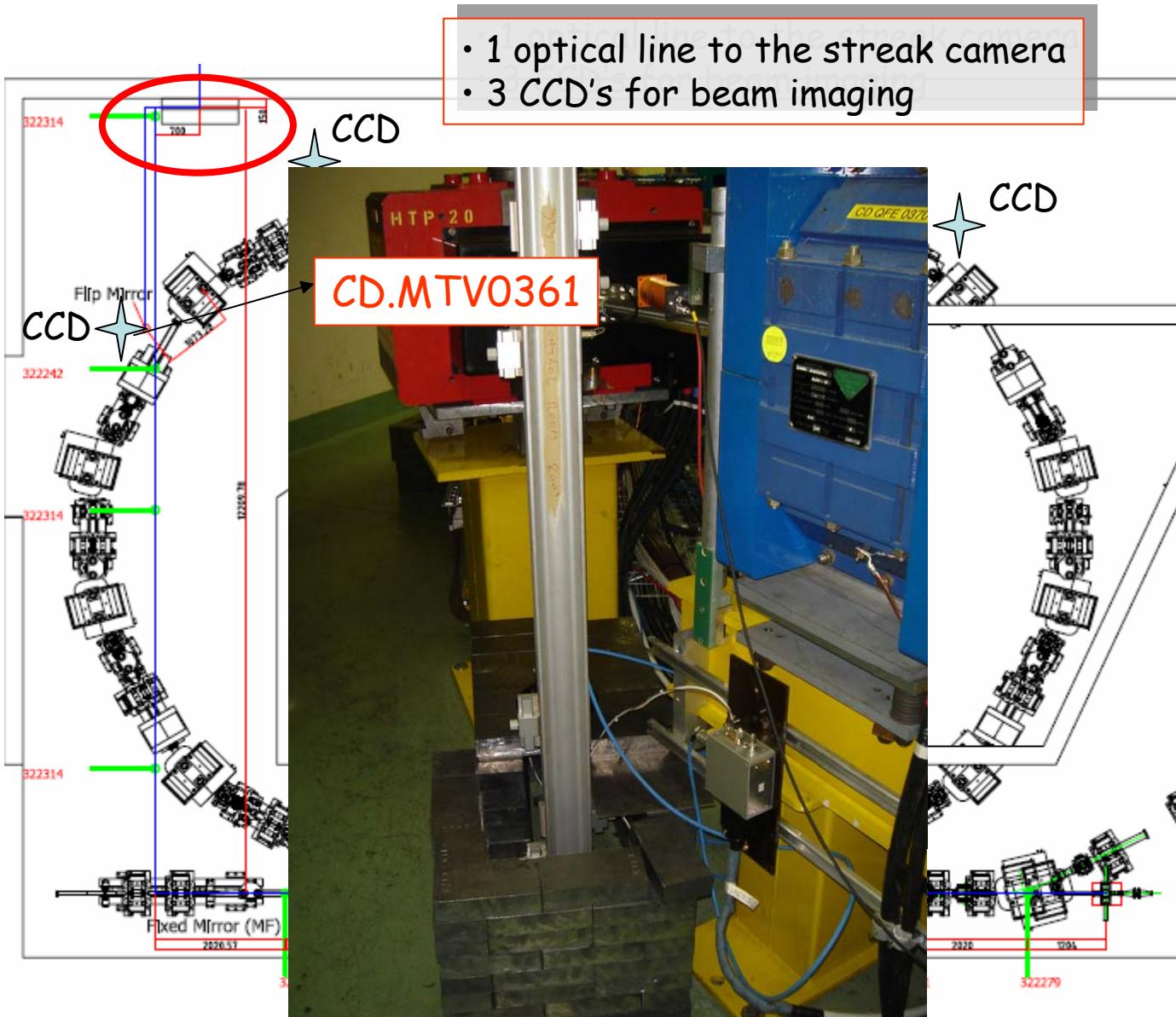


Segmented PMT with an embedded amplifier

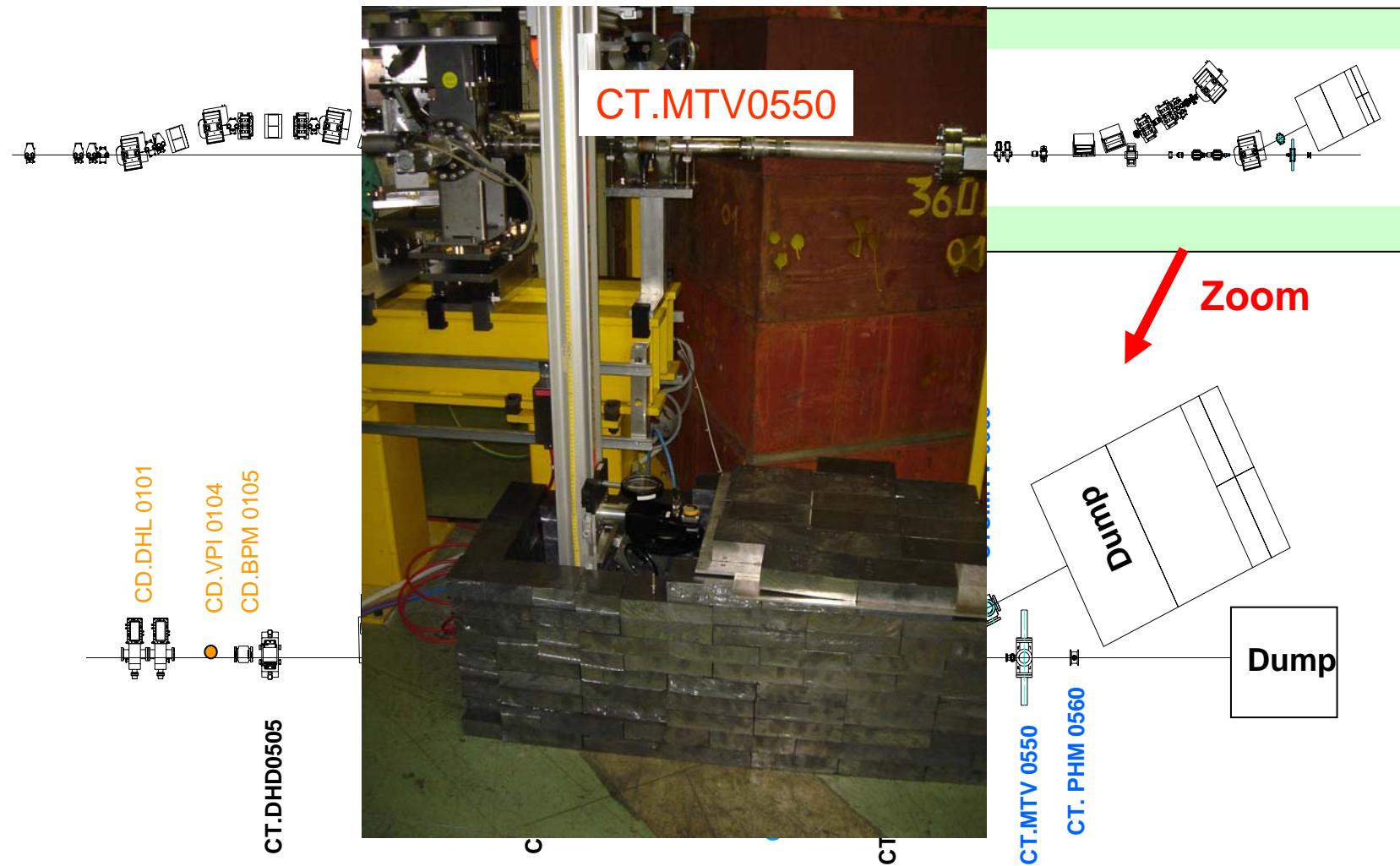


-
- No real difference observed so far with the system in Girder 10
 - More compact and less radioactive waste to have the amplifier in the Klystron gallery

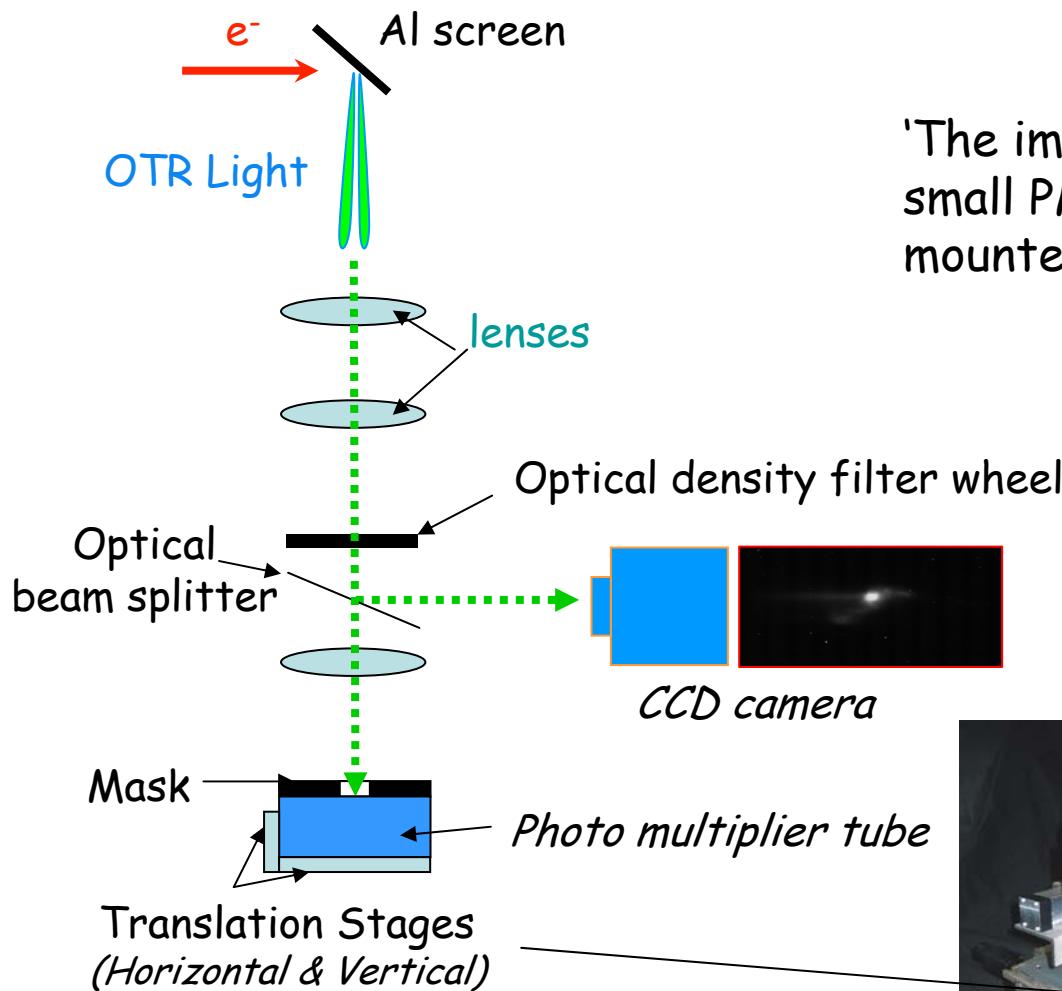
Delay loop installation



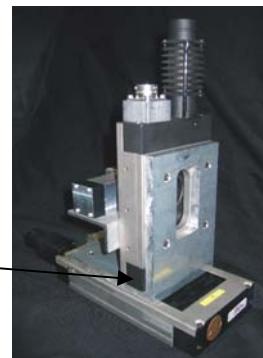
MTV's in the CT line



High dynamic range & time resolved emittance measurements

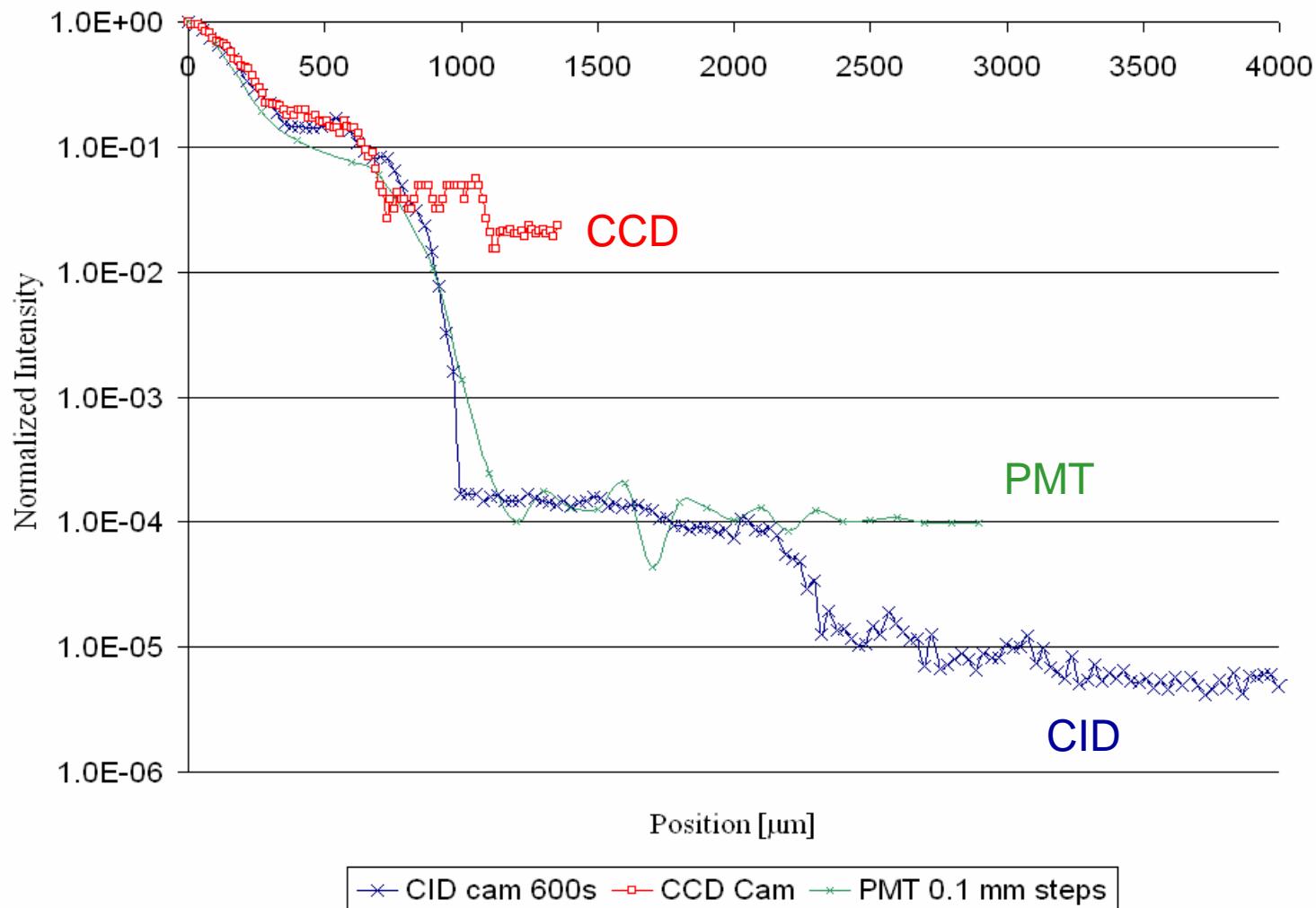


'The image plane is scanned by a small PMT with a small diaphragm mounted on two translation stages'



High dynamic range & time resolved emittance measurements

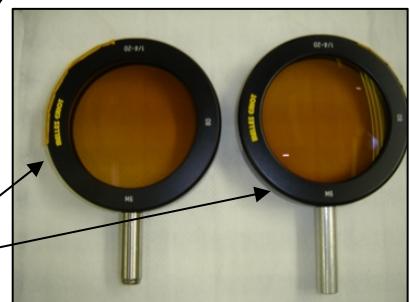
Measuring a laser beam profile in our lab



Radiation damage

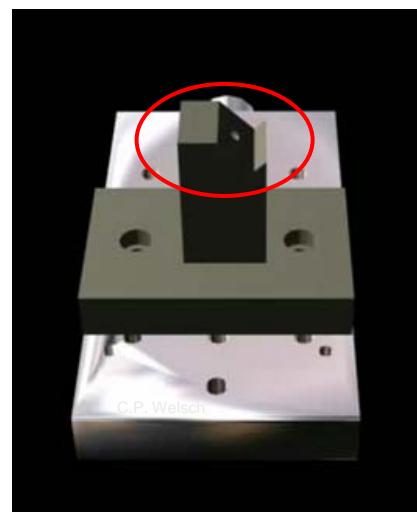
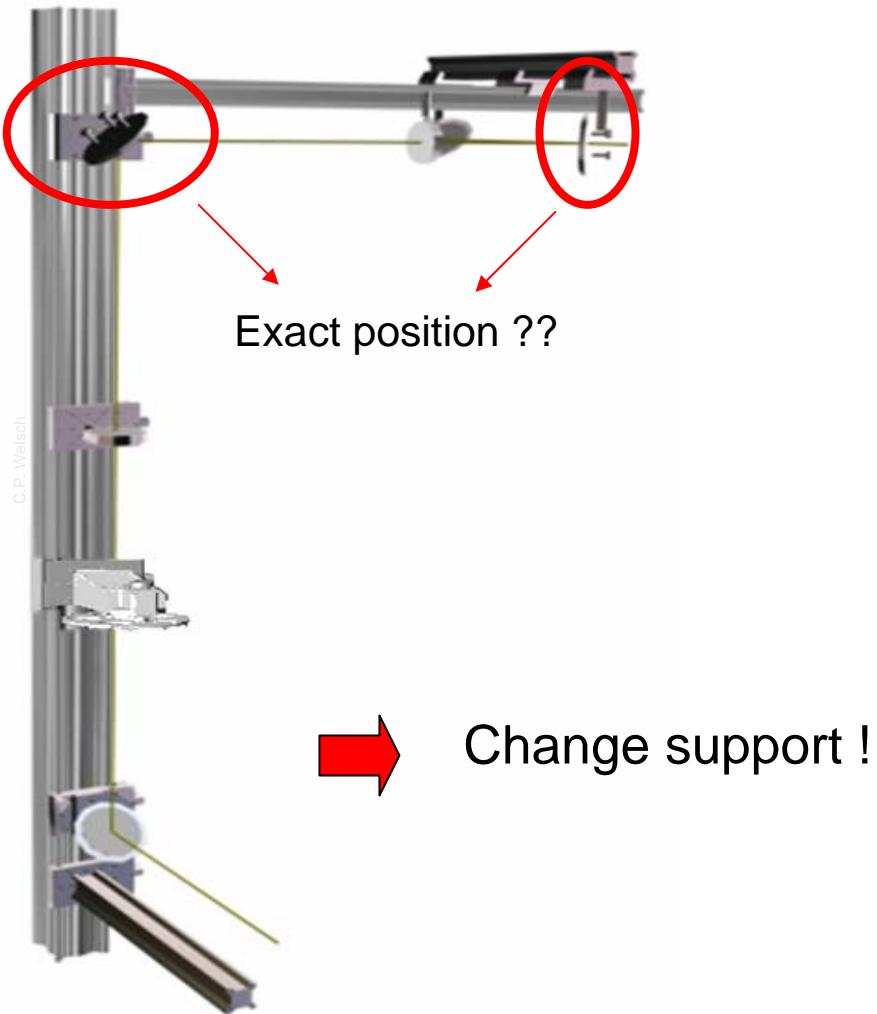
- After the first run 2005 (3 weeks), All CCD's have now at least 10% of dead pixels, two CCD's were replaced (>50% dead pixels)
- Lenses are getting dark

	Relative light output (%)	Relative losses (%)
no lens	1	--
new lens	0.939759036	1
CLS.MTV0440 lens 1 : 2 years	0.674698795	0.717948718
CLS.MTV0440 filed lens : 2 years	0.578313253	0.615384615
CL.MTV1030 lens 1 : 3 weeks	0.807228916	0.858974359
CL.MTV1030 field lens : 3 weeks	0.638554217	0.679487179



- for MTV0440 the light intensity reduction loss is 55.8% (two years of operation at 1-5Hz)
- for MTV1030 the light intensity reduction loss is 41.6% (3 weeks of operation at 33Hz)

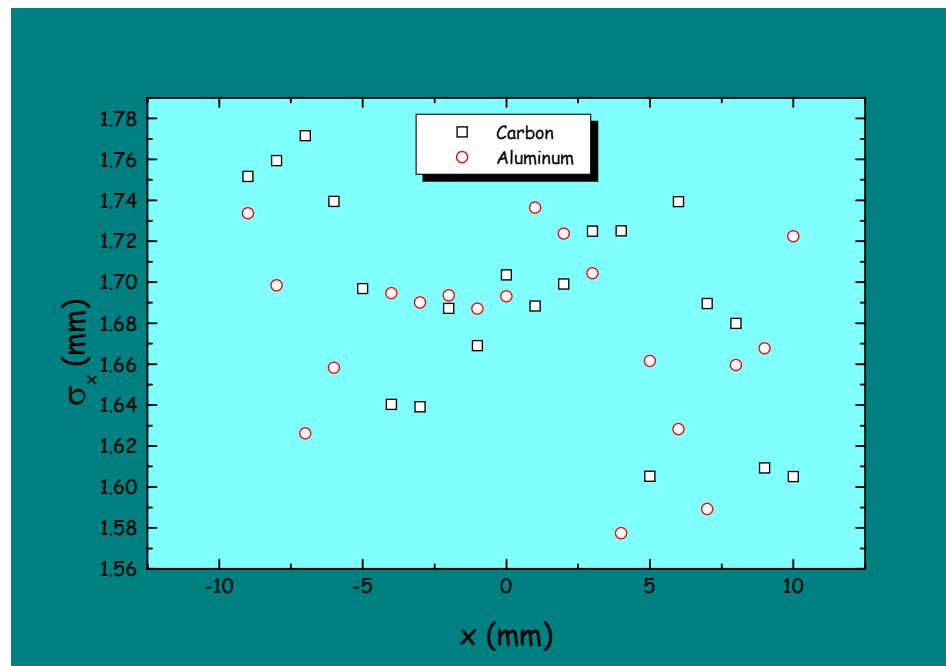
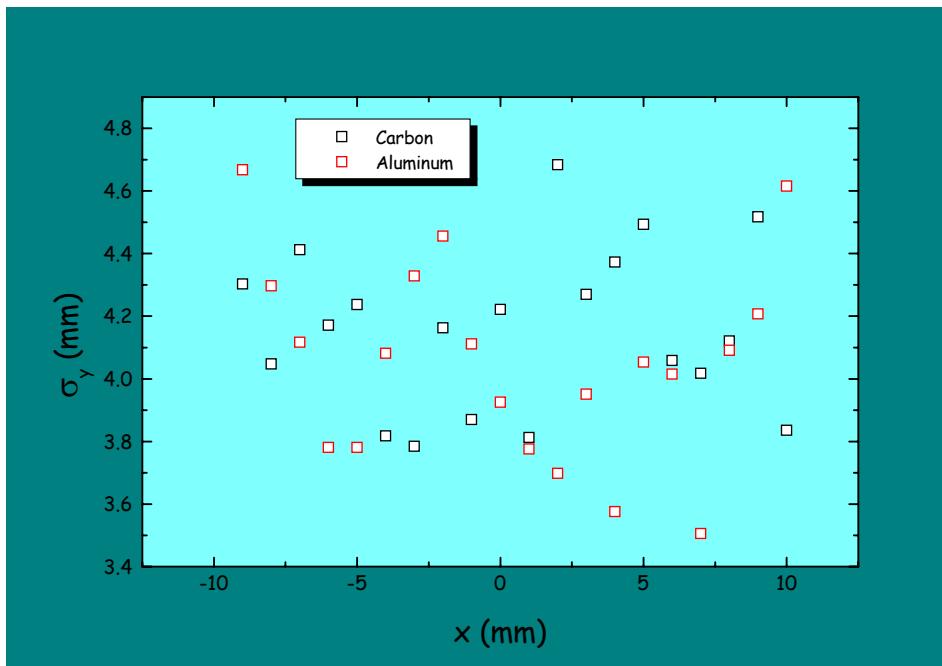
Improve the mechanical support for a better alignment, avoiding tilt angle





OTR light intensity vs position

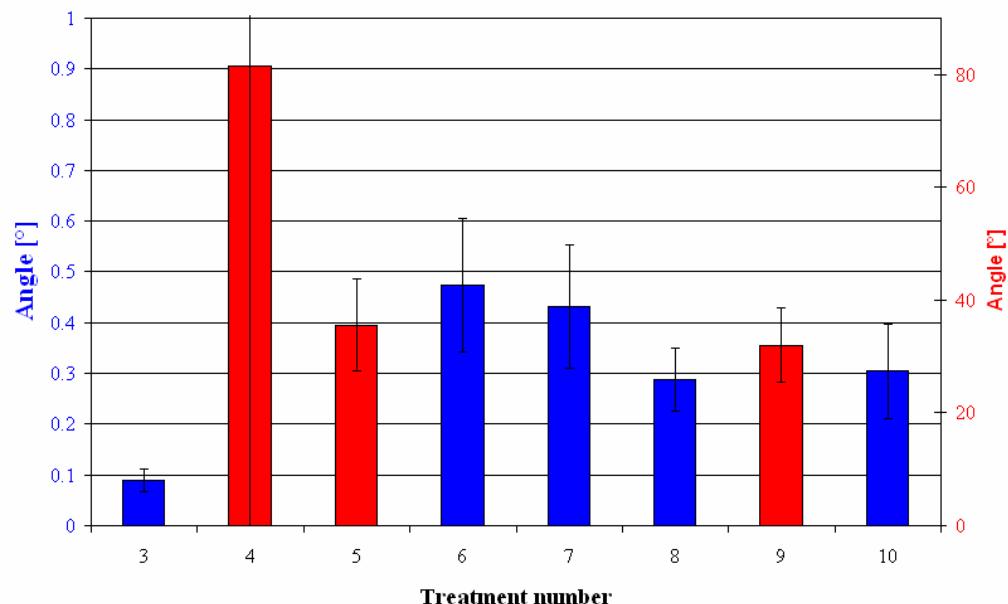
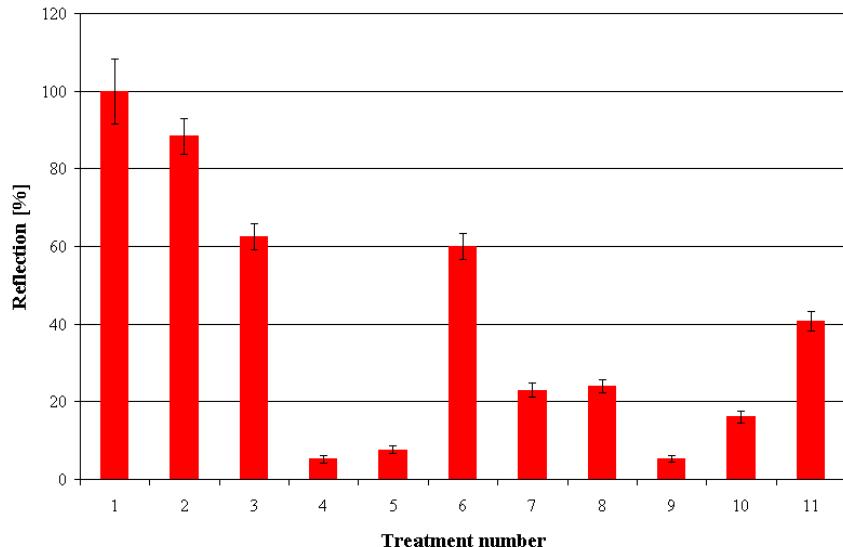
@CL.MTV1030 - 93.5MeV

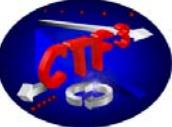




Number	Description of surface treatment
1	Direct illumination of photomultiplier tube
2	Mylar foil + Aluminum
3	Reference plate, mechanically polished
4	Silver-plated
5	Sand blasting
6	Degreasing
7	Degreasing + HNO_3 + HF
8	Degreasing + HNO_3 + HF + NaOH
9	Glass bead blasting
10	oxidation
11	unpolished

Diffusive surface : Surface treatments





CTF3 beam & diagnostic requirements



MTV's	Beam energy (MeV)	Beam charge (nC)	Beam size (mm)	Screen Size (mm)	Spatial resolution (mm/pixel)	Light intensity (photons)**
CL.MTV0165	0.140	10-7500 ⁺	>1	> Ø 50	0.2	$3 \cdot 10^4 - 2.4 \cdot 10^7$
CLS.MTV0440	20	7.5-5600*	>1	100x50	0.25	$1.5 \cdot 10^8 - 1.1 \cdot 10^{11}$
CL.MTV0500	20	-	>0.8	> Ø 30	0.1	-
CL.MTV1030	70	-	>0.4	> Ø 30	0.1	$2.6 \cdot 10^8 - 2 \cdot 10^{11}$
CLS.MTV1050	70	-	>1	100x50	0.25	-
CL.MTV0435	150	-	>0.15	> Ø 30	0.1	$3.2 \cdot 10^8 - 2.4 \cdot 10^{11}$
CLS.MTV0455	150	-	>1	100x50	0.25	

⁺ assuming commissioning conditions @100mA,100ns and nominal conditions @3.5A,1.56μs

* assuming 25% beam loss in the 3GHz bunching mechanism

** number of OTR photons emitted in the spectral band [400,600]nm

Camera	Minimum light intensity (photons) **	Price (CHF)
Proxitronic	>10 ⁴	20kCHF
CCD	>10 ⁷	1kCHF
CID (0.5Mrad)	> 10 ⁸	6kCHF
Vidicon	>10 ⁹	10kCHF

57dB range

** assuming a profile with 8 pixels per sigma



Cost of a system

Data Aquisition	
VME CRATE, fully equipped	2,500
Interface card for video signal, control & acquisition	2,000
CCD camera incl. connection	1,000
Cables (filter wheel, camera and motor)	2,000
Support	
Various manufacturing pieces for workshop	600
Optical rails	1,550
Optics	
Different small supports for lenses, filters, etc.	80
Lens holders	250
Lenses	2,000
Translation stages, columns	760
Adjustable Mirror (3d)	2,600
Control for adjustable mirror	2,200
Mirrors	500
Mounts	800
Optical filter wheel & filters	1,750
Screen / Support	
Support and fixing	150
OTR screen	560
Motorized arm, control	CERN
Flip mirror	CERN
Vacuum Chamber	
Design Work	CERN
Components	CERN
View ports, flanges, etc.	3,000
Construction	10,000
Shielding	
	1,000
Total:	35,300

